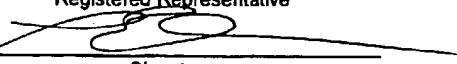


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18 May 2004
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Paul E. Rauch, Ph.D.
Name of Applicant, Assignee or
Registered Representative


Signature

Our File No.: CYP01-002-US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: H. Bamnolker et al.)
Serial No.: 09/927,863)
Filing Date: August 10, 2001) Examiner: Lynette T. Umez-Eronini
For: METHODS OF FORMING) Group Art Unit No.: 1765
SEMICONDUCTOR)
STRUCTURES HAVING)
REDUCED DEFECTS, AND)
ARTICLES AND DEVICES)
FORMED THEREBY)

Enter Amendment


5/31/2004

M.S. - AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Responsive to the Office Action of December 18, 2003, Applicants respectfully request reconsideration in light of the following remarks.